

Our Reference: MOR-221-A

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wakayama, et al.  
Serial Number: 09/601,390  
Filing Date: July 31, 2000  
Examiner/Art Group Unit: Hopkins, R./1724  
Title: FILTER MEDIUM FOR AIR FILTER AND  
PROCESS FOR PRODUCING THE SAME

AMENDMENT AFTER FINAL

Attn: Box AF  
Assistant Commissioner of Patents  
Washington, D.C. 20231

Sir:

If any charges or fees must be paid in connection with the following communication, they may be paid out of our Deposit Account No. 25-0115.

The Office Action dated September 16, 2002 has been received and carefully reviewed. Please amend the above-identified patent application as indicated below.

In the claims:

Please amend claims 11 and 14 as follows:

E1  
5 ~~11~~. (Thrice Amended) Local clean equipment comprising a chemical filter installed therein for trapping at least one of organic substances and inorganic substances and an air filter according to claim ~~2~~<sup>3</sup> installed therein for trapping suspended particulate substances in the air, said air filter being installed downstream of said chemical filter.

E2  
9 ~~14~~. (Amended) Local clean equipment as defined in claim ~~31~~<sup>8</sup> which comprises a clean bench, a clean booth, a wafer stocker, wafer transfer space, and semiconductor fabrication equipment.